

Notice of References CitedApplication/Control No.
09/747,779Applicant(s)/Patent Under
Reexamination
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2814

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U.S. PATENT DOCUMENTS

*		Document Number Country Code-Number-Kind Code	Date MM-YYYY	Name	Classification
	A	US-5,361,720	11-1994	Evetts et al.	117/91
	B	US-5,453,661	09-1995	Auciello et al.	313/497
	C	US-5,629,246	05-1997	Iyer, Ravi	427/99
	D	US-5,955,755	09-1999	Hirai et al.	257/295
	E	US-6,072,724	06-2000	Yamazaki, Hirokazu	365/185.2
	F	US-			
	G	US-			
	H	US-			
	I	US-			
	J	US-			
	K	US-			
	L	US-			
	M	US-			

FOREIGN PATENT DOCUMENTS

*		Document Number Country Code-Number-Kind Code	Date MM-YYYY	Country	Name	Classification
	N					
	O					
	P					
	Q					
	R					
	S					
	T					

NON-PATENT DOCUMENTS

*		Include as applicable: Author, Title Date, Publisher, Edition or Volume, Pertinent Pages)
	U	Van Zant, Microchip Fabrication: A Practical Guide to Semiconductor Processing, McGrawHill, 4th ed., pp.154,155,412
	V	
	W	
	X	<i>Marcos D. Pizarro-Crespo</i> 5/12/2003

*A copy of this reference is not being furnished with this Office action. (See MPEP § 707.05(a).)
Dates in MM-YYYY format are publication dates. Classifications may be US or foreign.